

Attorney Docket No.: <u>COOL-01301</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	App]	lication	of:
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Thomas W. Kenny et al.

Serial No.: 10/680,584

Filed: October 6, 2003

For: METHOD AND APPARATUS FOR

EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A HEAT PRODUCING DEVICE Group Art Unit: 3753

Examiner:

TRANSMITTAL LETTER

162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700

Customer No.: 28960

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Sir:

Enclosed please find an Information Disclosure Statement and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office.

You will also find enclosed the associated Transmittals, Electronic Information Disclosure Statements, and United States Patent and Trademark Office Acknowledgment Receipts for the electronically filed Information Disclosure Statement (EFS ID #59961); (EFS ID #59963) and (EFS ID #59964) filed on April 28, 2004.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. <u>08-1275</u>. An originally executed duplicate of this transmittal is enclosed for this purpose.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: 4-29-04

Thomas B. Haverstock

Reg. No.: 32,571

Attorneys for Applicants

CERTIFICATE OF MAILING (37 CFR§ 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP

Date



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Filed: October 6, 2003) STATEMENT

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EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A HEAT PRODUCING DEVICE 162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700

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Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

United States Patents or Published Patent Applications have been filed electronically (EFS ID #59961); (EFS ID #59962); (EFS ID #59963) and (EFS ID #59964). Applicants have become aware of the following printed publication which may be material to the examination of this application:

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This Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: 4-29-04

Thomas B. Haverstock Reg. No.: 32,571

Attorneys for Applicants

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Applicants: Thomas W. Kenny et al.

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(37 CFR § 1.98(b))	(Osc several offices if Necessary)	Filing Date: October 6, 2003	Group Art Unit: 3753
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FORM PTO-14 (Modified)	449	U.S. Department of Commerce Patent and Trademark Office	Attorney Docket No.: COOL-01301	Serial No.: 10/680,584		
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(37 CFR § 1.9		(Ose obverar offices in Necessary)	Filing Date: October 6, 2003	Group Art Unit: 3753		
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Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A **HEAT PRODUCING DEVICE**

Submission Type:

Information Disclosure Statement

Application Number:

10/680584

10/680584

EFS ID:

59961

Server Response:

Confirmation Code	Message		
IIICV/D1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application		
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ISYSS	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.		

First Named Applicant:

Thomas Kenny

Attorney Docket Number:

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Title of METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID Invention DELIVERY FOR COOLING A HEAT PRODUCING DEVICE

Application Number: 10/680584 *10/680584*

ate: 2003-10-06

First Named Applicant: Thomas W. Kenny

Confirmation Number: 5276

Attorney Docket Number:

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Invention

METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A HEAT PRODUCING

Application Number:

10/680584

Confirmation Number: 5276 First Named Applicant: Thomas Kenny

Attorney Docket Number:

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Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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Information Disclosure Statement

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ij	38	5203401	1993-04-20	Hamburgen et al.
٦Ì	39	5218515	1993-06-08	Bernhardt
٦İ	40	5219278	1993-06-15	Van Lintel
7	41	5232047	1993-08-03	Matthews

Information Disclosure Statement

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UNITED STATES PATENT AND TRADEMARK OFFICE ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1
Stylesheet Version v1.1.1

Title of Invention

METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A HEAT PRODUCING DEVICE

Submission Type:

Information Disclosure Statement

Application Number:

10/680584

10/680584

EFS ID:

59962

Server Response:

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First Named Applicant:

Thomas Kenny

Attorney Docket Number:

Timestamp:

2004-04-28 13:29:02 EDT

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Acknowledgement Receipt

Page 2 of 2

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package-data	package-data.dtd	27025
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Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered Attorneys,ou=Patent

and Trademark Office, ou = Department of Commerce, o = U.S.

Name:

Government,c=US

Transmittal Page 1 of 2

TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID Invention DELIVERY FOR COOLING A HEAT PRODUCING DEVICE

Application Number: 10/680584 *10/680584*

Date: 2003-10-06

First Named Applicant: Thomas W. Kenny

Confirmation Number: 5276

Attorney Docket Number:

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I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.

Thomas B. Haverstock Registered Number: 32571 Attorney	Submitted by:	Elec. Sign.	Sign. Capacity
<u> </u>	Thomas 8. Haverstock	/tbh/	20140
	Registered National, 3237 i		(a) (a)

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Transmittal Page 2 of 2

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us-ids.dtd
us-ids.xsl

Comments

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention

METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A HEAT PRODUCING

Application Number: 10/680584

10/680584

Confirmation Number: 5276
First Named Applicant: Thomas Kenny

Attorney Docket Number:

Search string:

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or \$965001 or \$965813 or \$978220 or \$997713 or \$998240 or 6007309 or 6010316 or 6013164 or 6019882 or 6054034 or

6068752).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

	init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
lÌ		1	5383340	1995-01-24	Larson et al.			
Ì	T	2	5421943	1995-06-06	Tam et al.]		
Ì	\neg	3	5427174	1995-06-27	Lomolino et al.	j		
li	可	4	5436793	1995-07-25	Sanwo et al.	Ì		
l		5	5459099	1995-10-17	Hsu			
li	\neg	6	5508234	1996-04-16	Dusabion, Sr. et al.]		
li	\dashv					ī		

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Information Disclosure Statement

Page 3 of 3

42	5978220	1999-11-02	Frey et al.
43	5997713	1999-12-07	Beetz, Jr. et al.
44	5998240	1999-12-07	Hamilton et al.
45	6007309	1999-12-28	Hartley
46	6010316	2000-01-04	Haller et al.
47	6013164	2000-01-11	Paul et al.
48	6019882	2000-02-01	Paul et al.
49	6054034	2000-04-25	Soane et al.
50	6068752	2000-05-30	Dubrow et al.

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Date

	7	5514832	1996-05-07	Ousablon, Sr. et al.
	8	5514906	1996-05-07	Love et al.
\Box	9	5544696	1996-08-13	Leland
	10	5548605	1996-08-20	Benett et al.
	- 11	5575929	1996-11-19	Yu et al.
	12	5579828	1996-12-03	Reed et al.
	13	5585069	1996-12-17	Zanzucchi et al.
	14	5641400	1997-06-24	Kaltenbach et al.
	15	5692558	1997-12-02	Hamilton et al.
	16	5696405	1997-12-09	Weld
	17	5703536	1997-12-30	Davis et al.
	18	5704416	1998-01-06	Larson et al.
	19	\$727618	1998-03-17	Mundinger et al.
	20	\$759014	1998-06-02	Van Untel
	21	5763951	1998-06-09	Hamilton et al.
	22	5774779	1998-06-30	Tuchinskiy
	23	\$800690	1998-09-01	Chow et al.
	24	5801442	1998-09-01	Hamilton et al.
	25	5835345	1998-11-10	Staskus et al.
	26	5836750	1998-11-17	Cabuz
	27	5858188	1999-01-12	Soane et al.
	28	5863708	1999-01-26	Zanzucchi et al.
	29	5869004	1999-02-09	Parce et al.
	30	5870823	1999-02-16	Bezama et al.
	31	5874795	1999-02-23	Sakamoto
	32	5876655	1999-03-02	Fisher
	33	\$880017	1999-03-09	Schwiebert et al.
	34	5880524	1999-03-09	XIe
	35	5901037	1999-05-04	Hamilton et al.
	36	5936192	1999-08-10	Tauchi
	37	5940270	1999-08-17	Puckett
	38	5942093	1999-08-24	Rakestraw et al.
	39	5964092	1999-10-12	Tozuka et al.
	40	5965001	1999-10-12	Chow et al.
	41	5965813	1999-10-12	Wan et al.

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UNITED STATES PATENT AND TRADEMARK OFFICE **ACKNOWLEDGEMENT RECEIPT**

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A **HEAT PRODUCING DEVICE**

Submission Type:

Information Disclosure Statement

Application Number:

10/680584

10/680584

EFS ID:

59964

Server Response:

Confirmation Code	Message
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ICON1	5276
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First Named Applicant:

Thomas Kenny

Attorney Docket Number:

Timestamp:

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Name:

Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered Attorneys,ou=Patent and Trademark Office, ou = Department of Commerce, o = U.S.

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Transmittal Page 1 of 2

Page 2 of 2

COOL01301D-usidst.xml

Documents being submitted

us-ids

Transmittal

TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID Invention DELIVERY FOR COOLING A HEAT PRODUCING DEVICE

Application Number: 10/680584 *10/680584*

Date: 2003-10-06

First Named Applicant: Thomas W. Kenny

Confirmation Number: 5276

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock	/tbh/	
Registered Number: 32571		Attorney

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Comments

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Information Disclosure Statement

Signature

Examiner Name	Date

Page 2 of 2

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention

METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A HEAT PRODUCING DEVICE

Application Number:

10/680584

10/680584

Confirmation Number: 5276

First Named Applicant: Thomas Kenny

Attorney Docket Number:

Search string:

(6632655 or 20010016985 or 20010024820 or

20010044155 or 20010045270 or 20010046703 or 20010055714 or 20020011330 or 20020134543).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

Init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6632655	2003-10-14	Mehta et al.	81		

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20010016985	2001-08-30	Insley et al.	Al		
	2	20010024820	2001-09-27	Mastromatteo et al.	Al		
	3	20010044155	2001-11-22	Paul et al.	Al		
	4	20010045270	2001-11-29	8hatti et al.	Al		
	5	20010046703	2001-11-29	Burns et al.	Al		
	6	20010055714	2001-12-27	Cettour-Rose et al.	Al		
	7	20020011330	2002-01-31	Insley et al.	Al		
	8	20020134543	2002-09-26	Estes et al.	Αl		

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UNITED STATES PATENT AND TRADEMARK OFFICE **ACKNOWLEDGEMENT RECEIPT**

Electronic Version 1.1 Stylesheet Version v1.1.1

Title of Invention

METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A **HEAT PRODUCING DEVICE**

Submission Type:

Information Disclosure Statement

Application Number:

10/680584

10/680584

EFS ID:

59963

Server Response:

Confirmation Code	Message
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First Named Applicant:

Thomas Kenny

Attorney Docket Number:

Timestamp:

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Page 2 of 2

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Digital Certificate Holder cn=Thomas B. Haverstock,ou=Registered Attorneys,ou=Patent and Trademark Office,ou=Department of Commerce,o=U.S.

Government,c=US

Transmittal Page 1 of 2

Page 2 of 2

COOL01301C-usidst.xml

Documents being submitted

us-ids

Transmittal

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Electronic Version v1.1

Stylesheet Version v1.1.0

Title of METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID Invention DELIVERY FOR COOLING A HEAT PRODUCING DEVICE

Application Number: 10/680584 *10/680584*

Date: 2003-10-06

First Named Applicant: Thomas W. Kenny

Confirmation Number: 5276

Attorney Docket Number:

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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

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Lomments

Comments

Electronic Version v18
Stylesheet Version v18.0

Title of

METHOD AND APPARATUS FOR EFFICIENT VERTICAL FLUID DELIVERY FOR COOLING A HEAT PRODUCING

Application Number: 10/680584

10/680584

Confirmation Number: 5276
First Named Applicant: Thomas Kenny

Attorney Docket Number:

Search string:

(6090251 or 6096656 or 6100541 or 6101715 or 6119729 or 6126723 or 6129145 or 6129260 or 6131650 or 6146103 or 6154363 or 6159353 or 6171067 or 6174675 or 6176962 or 6186660 or 6210986 or 6216343 or 6221226 or 6227809 or 6234240 or 6238538 or 6277257 or 6287440 or 6301109 or 6313992 or 6317326 or 6321791 or 6322753 or 6324058 or 6337794 or 6351384 or 6388317 or 6396706 or 6400012 or 6406605 or 6415860 or 6416642 or 6417060 or 6424531 or 6443222 or 6444461 or 6457515 or 6495015 or 6537437 or 6543521

or 6553253 or 6572749 or 6588498 or 6591625).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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$\overline{}$	1	6090251	2000-07-18	Sundberg et al.]		
乛	2	6096656	2000-08-01	Matzke et al.	j		
乛	3	6100541	2000-08-08	Nagle et al.	Ī		
T	4	6101715	2000-08-15	Fuesser et al.	Ī		
	5	6119729	2000-09-19	Oberholzer et al.	1		
	6	6126723	2000-10-03	Drost et al.	1		

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Information Disclosure Statement

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	43	6457515	2002-10-01	Vafai et al.	BI
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П	45	6537437	2003-03-25	Galambos et al.	Bl
П	46	6543521	2003-04-08	Sato et al.	BI
П	47	6553253	2003-04-22	Chang	B1
	48	6572749	2003-06-03	Paul et al.	B1
	49	6588498	2003-07-08	Reysin et al.	B1
П	50	6591625	2003-07-15	Simon	BI

Signature

Examiner Name	Date

Information Disclosure Statement

7 7	6129145	2000-10-10	Yamamoto et al.	
8	6129260	2000-10-10	Andrus et al.	
9	6131650	2000-10-17	North et al.	
10	6146103	2000-11-14	Lee et al.	
11	6154363	2000-11-28	Chang	
12	6159353	2000-12-12	West et al.	
13	6171067	2001-01-09	Parce	81
14	6174675	2001-01-16	Chow et al.	B1
15	6176962	2001-01-23	Soane et al.	В١
16	6186660	2001-02-13	Kopf-Sili et al.	B1
17	6210986	2001-04-03	Arnold et al.	В1
18	6216343	2001-04-17	Leland et al.	B1
19	6221226	2001-04-24	Kopf-Sill	B1
20	6227809	2001-05-08	Forster et al.	B1
21	6234240	2001-05-22	Cheon	BI
22	6238538	2001-05-29	Parce et al.	BI
23	6277257	2001-08-21	Paul et al.	B1
24	6287440	2001-09-11	Arnold et al.	В1
25	6301109	2001-10-09	Chu et al.	B1
26	6313992	2001-11-06	Hildebrandt	81
27	6317326	2001-11-13	Vogel et al.	B1
28	6321791	2001-11-27	Chaw	B1
29	6322753	2001-11-27	Lindberg et al.	B1
30	6324058	2001-11-27	Hsiao	B1
31	6337794	2002-01-08	Agonafer et al.	B1
32	6351384	2002-02-26	Darkoku et al.	BI
33	6388317	2002-05-14	Reese	B1
34	6396706	2002-05-28	Wohlfarth	B1
35	6400012	2002-06-04	Miller et al.	B1
36	6406605	2002-06-18	Moles	B1
37	6415860	2002-07-09	Kelly et al.	B1
38	6416642	2002-07-09	Alajoki et al.	B1
39	6417060	2002-07-09	Tavkhelidze et al.	B1
40	6424531	2002-07-23	Bhatti et al.	B1
41	6443222	2002-09-03	Yun et al.	B1

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